35.C11946



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

C. Dexter

AKIRA FUNAKOSHI, ET AL.

Group Art Unit:

Application No.: 08/801,464

Filed: February 18, 1997

For:

SUBSTRATE CUTTING METHOD

AND SUBSTRATE CUTTING

APPARATUS

Date: October 6, 1999

The Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below:

			CLAIMS AS AM	ENDED	· • • · · · · · · · · · · · · · · · · ·	
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	22	MINUS	20	= 2	x \$9 \$18	\$ 36.00
INDEP. CLAIMS	6	MINUS	4	= 2	x \$39 \$78	\$156.00
Fee for Mu	_					
	\$192.00					

	°Verified Statement claiming s not filed previously.	mall entity status is enclosed, if				
X	A check in the amount of \$192.	00 is enclosed.				
	Charge \$ to Deposit Acc this sheet is enclosed.	ount No. 06-1205. A duplicate of				
' <u>X</u>	Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Assistant Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.					
x	A check in the amount of \$870.00 to cover the fee for a three month extension is enclosed.					
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.					
x	Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.					
		Respectfully submitted,				
,		Attorney for Applicants Registration No. 33,326				
FITZPATRICK, CELLA, HARPER & SCINTO						
	kefeller Plaza rk, New York 10112-3801					
Facsimile: (212) 218-2200						

SEW:rle

OCT 0 6 1999 S

PATENT APPLICATION

35.C11946

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

: Examiner: C. Dexter

AKIRA FUNAKOSHI, ET AL.

: Group Art Unit: 3724

Application No.: 08/801,464

: Filed: February 18, 1997

: For: SUBSTRATE CUTTING METHOD)

AND SUBSTRATE CUTTING :

APPARATUS

) October 6, 1999

The Assistant Commissioner for Patents Washington, D.C. 20231

REQUEST FOR APPROVAL TO AMEND THE DRAWINGS

Sir:

In accordance with U.S. Patent and Trademark Office procedures, enclosed are duplicate informal drawings of Figures 3, 4 and 5, with proposed amendments shown in red ink. Applicants request approval to amend the drawings as follows:

IN FIGURE 3

Reorient reference characters "SR1-1", "SR1-2", "SR1-3" and "SR1-20" as shown.

IN FIGURE 4

Reorient reference characters "SR1-1", SR1-2", "SR1-3", "SR1-10", "SR1-11", "SR1-12", "SR1-13" and "SR1-20" as shown.

IN FIGURE 5

Reorient reference characters "SR1-1", "SR1-10", "SR1-11", "SR1-20", "SR1-21", "SR1-30", "SR1-31" and "SR1-40" as shown.

Favorable consideration is requested.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010.

All correspondence should be directed to our address listed below.

Respectfully submitted,

Attorney for Applicants Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

SEW:rle